

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	Confirmation No.: 4751
Francisco Arias et al.	Group Art Unit: 1791
Serial No.: 10/727,124	Examiner: Mathieu D. Vargot
Filing Date: December 3, 2002	
Title: METHOD OF MANUFACTURING MICRONEEDLE STRUCTURES USING SOFT LITHOGRAPHY AND PHOTOLITHOGRAPHY	

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an Information Disclosure Statement submitted for the Examiner's consideration. A PTO-1449 form listing the references accompanies this paper. Applicants would appreciate the Examiner's initialing and returning the form to indicate that the references have been reviewed and made of record.

The attached English-language abstracts represent counsel's best understanding of the Japanese references. While machine translations of the references are believed to be available at http://www.ipdl.inpit.go.jp/homepg_e.ipdl, the reliability and intelligibility of these translations leave much to be desired.

This Information Disclosure Statement is not intended as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that any of the above references constitutes prior art to the present application within the meaning of 35 U.S.C. § 102.

This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits, and accordingly a fee of \$180.00 is being paid with the filing of this statement.

The Office is hereby authorized to charge any additional fees under 37 CFR §§ 1.16, 1.17, and 1.21 which may be required by this paper, or to credit any overpayment, to Deposit Account No. 50-0311.

Respectfully submitted,

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